

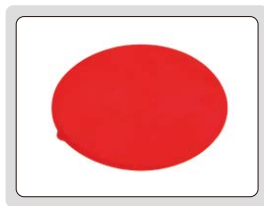
GRINDER AND POLISHER (BASIC TYPE) CODE MLP-GP314



- Double wheels, rotation direction can be selected
- Smooth rotation, low noise
- Water cooling device, prevent samples from overheating and destroying structure
- Replaceable silicon carbide paper and polishing cloth for grinding and polishing process



silicon carbide paper (included)



polishing cloth (included)



magnetic pad (optional)



anti-stick disc (optional)

SPECIFICATION

Wheel diameter	Ø203mm
Wheel rotation speed	0~1400r/min (stepless adjustable)
Wheel rotation direction	Clockwise or counterclockwise
Power supply	AC 220V, 50Hz
Input power	0.75KW
Dimension	755×700×310mm
Weight	50kg

STANDARD DELIVERY

Main unit	1pc
Silicon carbide paper	5 pcs each, (240, 400, 800, 1200), 20 pcs in total
Polishing cloth	4 pcs
Polishing agent	1pc (W2.5, 500ml)

OPTIONAL ACCESSORY

Silicon carbide paper	MLP-SZD□□*	50 pcs/box, select granularity: 120, 180, 240, 400, 600, 800, 1000, 1200, 1500, 2000
Polishing cloth	MLP-CT6	15 pcs/box, long velvet silk material
Diamond polishing liquid	MLP-DLA□□*	500ml, select granularity (µm): W40, W28, W20, W14, W9, W7, W5, W3.5, W2.5, W1.5, W1.0, W0.5, W0.25
Magnetic pad	MLP-AD1	Ø203mm
Anti-stick disc	MLP-DC1	Ø203mm

* □□ is granularity specification, for example, code **MLP-DLA40** stands for diamond polishing liquid 40µm granularity